As a below named inventor, I hereby declare:

That my residence, post office address and citizenship are as stated below next to my name.

That I verily believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural inventors are named below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

METAL-ASSISTED CHEMICAL ETCH POROUS SILICON FORMATION METHOD

	the specification of which	(check one)						
	() is attached hereto.	(Gileon Sile)	•					
	() was filed on Application Serial No and was amended on							
-	That I have reviewe amendment referred to about		ntents of the above-identified spec	ification, includ	ling the claims, as	amended by any		
That I acknowledge the duty to disclose information known to be material to patentability of this app Title 37, Code of Federal Regulations, §1.56(a).					his application in	accordance with		
The training the training that the	That I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for pater inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate on invention having a filing date before that of the application on which priority is claimed:							
	Prior Foreign Application(s)				Priority Claimed			
					() Yes	() No		
å	(Number)	(Country)	(Day/Month/Year I	Filed)				
					() Yes	() No		
J	(Number)	(Country)	(Day/Month/Year I	Filed)				
					() Yes	() No		
	(Number)	(Country)	(Day/Month/Year I	Filed)				
	That I hereby claim the benefit under Title 35, United States Code, §120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code, §112, I acknowledge the duty to disclose material information as defined in Title 37, Code of Federal Regulations, §1.56(a) which occurred between the filing date of the prior application and the national or PCT international filing date of this application:							
	United States Application(s)							
	(Application Serial No.)	cation Serial No.) (F		(Status)-	(Status)-(Patented, pending, abandoned)			
	(Application Serial No.)		(Filing Date)	(Status)-	-(Patented, pendi	ng, abandoned)		
	(Application Serial No.)		(Filing Date)	(Status)-	-(Patented, pendir	ng, abandoned)		

That all statements is therein of my own knowledge are true and that all the pents made on information and belief are believed to be the and further that these statements were made with the howledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

I hereby appoint the following attorneys and agents, with full power of substitution and revocation, to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith and request that all correspondence and telephone calls in respect to this application be directed to GREER, BURNS & CRAIN, LTD., Suite 8660 - Sears Tower, 233 South Wacker Drive, Chicago, Illinois 60606, Telephone No. (312) 993-0080:

Attorney Roger D. Greer

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